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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re U.S. Patent Application of: ) Attorney Docket: 4425-154**

**LAI ET AL.**

**) Group Art Unit: 2823**

**Serial No.: 09/888,494**

**) Examiner: Long Pham**

**Filed: June 26, 2001**

**For: METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR  
TYPE FIELD EFFECT TRANSISTOR**

**AMENDMENT**

Honorable Commissioner for Patents  
Washington, D.C. 20231

Sir:

This paper is in response to the Official Action dated July 9, 2002. In that Official Action, Claims 1-18 are rejected under 35 U.S.C. §103(a). Kindly amend the application in accordance with the following particulars: